



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael L. McSwiney, et al.

Serial No.: 10/764193

Filed: January 23, 2004

For: Forming A Silicon Nitride Film

Group Art Unit:

Examiner:

Atty. Dkt. No.: ITL.1056US (P17793)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant submits the references listed on the attached form PTO 1449 together with any required copies of such references.

This statement is being filed before the receipt of a first Office action on the merits.
Please apply any charges or credits to Deposit Account 20-1504 (ITL.1056US).

Respectfully submitted,

Date:

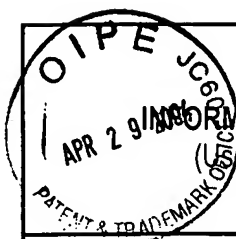
April 26, 2004

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Date of Deposit: April 26, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Rebecca R. Ginn



ATTY DOCKET NO. ITL.1056US (P17793)	SERIAL NO. 10/764,193
APPLICANT(S): MICHAEL MCSWINEY, ET AL.	
FILING DATE: January 23, 2004	GROUP ART UNIT:

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.							
	K.							
	L.							
	M.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

N.	Inventors: Michael L. McSwiney and Michael D. Goodner, Patent Application entitled: <i>Low-Temperature Silicon Nitride Deposition</i> , filed July 30, 2003, Serial No. 10/631,627 , Patent Application has 15 pages and 4 pages of drawings
O.	Author: SCHUMACHER, A UNIT OF AIR PRODUCTS AND CHEMICALS, INC.; entitled: <i>BTBAS Silicon Nitride</i> ; 1 page; www.schumacher.com/btbas , date unknown.
P.	
Q.	
R.	
S.	
T.	

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.